



Patent (+) plus sign (+) inside this box.

Substitute for form 1449A/PTO

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known

Application Number	09/680777
Filing Date	10/06/2000
First Named Inventor	Jonathan F. Gorrell et al
Group Art Unit	1746
Examiner Name	
Attorney Docket Number	SC11210ZP

Sheet 2 of 2

## OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
Sub	BC ✓	PAUL, O. et al.; Sacrificial Aluminum Etching for CMOS Microstructures; pages 523-528; 0-7803-3744-1/97; IEEE	
Sub	BD ✓	ROGER T. HOWE; Applications of Silicon Micromachining to Resonator Fabrication; IEEE International Frequency Control Symposium; 1994; pages 2-7; 0-7803-1945-1/94; IEEE	
Sub	BE ✓	International Search Report	

Examiner  
Signature

*Alan Ober*

Date  
Considered

2/16/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation, if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number. <sup>2</sup> Applicant is to place a check mark here if English Language Translation is attached.



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<b>Substitute for form 1449A/PTO</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)		<b>Complete if Known</b>			
		Application Number	09/680777		
		Filing Date	10/06/2000		
		First Named Inventor	Jonathan F. Gorrell et al.		
		Group Art Unit	<del>748</del> 1763		
Sheet	1	of	2	Examiner Name	Olsen
				Attorney Docket Number	SC11210ZP

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U. S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. 1	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. 1	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>2</sup> (if known)			
	BA	WO	95/00258		Alley et al.	01-05-1995	
<i>Two</i>	BB	DE	195 06 404 C1	✓	Biebl	03-14-1996	

Examiner Signature	<i>Ala Olsen</i>	Date Considered	2-16-04
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation, if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number. <sup>2</sup> See Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English Language Translation is attached.

Form PTO-1449	LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use Several Sheets if Necessary)	ATTY. DOCKET NO.	SERIAL NO.
		SC11210ZP	09/680,777
		Jonathan F. Gorrell et al.	
		FILING DATE	GROUP
		October 6, 2000	1763

REFERENCE DESIGNATION  
U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	GRANT DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES	NO
	AQ					<input type="checkbox"/>	<input type="checkbox"/>
	AP					<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>AW</i>	AQ	Gregory Mulhern et al., "Supercritical Carbon Dioxide Drying of Microstructures", The 7th Int'l Conference on Solid-State Sensors and Actuators - Digest of Technical papers, June 7-10, 1993, Pages 296-299.
	AR	

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